

***IN THE UNITED STATES PATENT AND TRADEMARK OFFICE***

Applicant: Geun-Young YEOM et al.

Title: 3-GRID NEUTRAL BEAM SOURCE USED FOR ETCHING  
SEMICONDUCTOR DEVICE

Appl. No.: Unassigned

Filing Date: April 1, 2004

Examiner: Unassigned

Art Unit: Unassigned

**PRELIMINARY AMENDMENT**

Mail Stop NON-FEE AMENDMENT  
Commissioner for Patents  
PO Box 1450  
Alexandria, Virginia 22313-1450

Sir:

Prior to examination of the present Application, Applicant respectfully requests that the application be amended as follows:

**Amendments to the Specification** begin on page 2 of this document.

**Remarks/Arguments** begin on page 4 of this document.

Please amend the application as follows: